



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): M. MASUDA et al  
Serial No.: 10/743,882  
Filed: December 24, 2003  
For: A SEMICONDUCTOR DEVICE AND A METHOD OF  
MANUFACTURE  
  
Group: 2815  
Examiner: S. CLARK

**INFORMATION DISCLOSURE STATEMENT**  
**UNDER 37 CFR 1.97 AND 1.98**

**Mail Stop: Amendment**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

June 24, 2005

Sir:

Upon granting of the concurrently filed Request for Continued Examination (RCE), entry and formal consideration therefor of this IDS, which is authorized under 37 CFR §1.114(c), is respectfully requested.

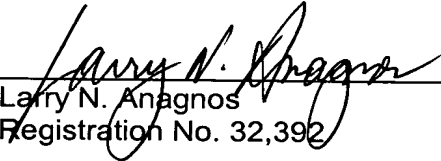
Applicants, through their undersigned representative, are submitting herewith a copy as well as a listing therefor in Form PTO/SB/08A of U.S. Patent 5,963,794, for the USPTO's consideration and in keeping with the duty of disclosure requirements.

This Information Disclosure Statement is being filed as part of a Submission under 37 CFR §1.114, and, therefore, meets the requirements pursuant to 37 CFR §1.97(b)(4). Acceptance and formal entry therefor of this submission, pursuant to 37 CFR §1.114, along with an acknowledgement of such entry as well as formal consideration thereof by the Examiner is respectfully requested.

Applicants request any shortage or excess in fees in connection with the filing of this paper, including extension of time fees, and for which no other form of payment is offered, be charged or credited to Deposit Account No. 01-2135 (Case: 501.39155VC2).

Respectfully submitted,

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